

<b>Notic of R ferences Cited</b>	Application/Control No. 10/642,912	Applicant(s)/Patent Under Reexamination LECRONE ET AL.	
	Examiner Gabriel L. Chu	Art Unit 2114	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-3,704,453	11-1972	Blackwell et al.	710/21
*	B	US-5,210,865	05-1993	Davis et al.	714/6
*	C	US-5,435,004	07-1995	Cox et al.	707/205
*	D	US-5,487,160	01-1996	Bemis, Edward D.	711/114
*	E	US-5,574,851	11-1996	Rathunde, Dale F.	714/7
*	F	US-5,615,352	03-1997	Jacobson et al.	711/114
*	G	US-5,655,154	08-1997	Jain et al.	719/310
*	H	US-5,809,224	09-1998	Schultz et al.	714/7
*	I	US-6,209,059	03-2001	Ofer et al.	711/114
*	J	US-6,216,211	04-2001	McBrearty et al.	711/162
*	K	US-6,598,134	07-2003	Ofek et al.	711/162
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.